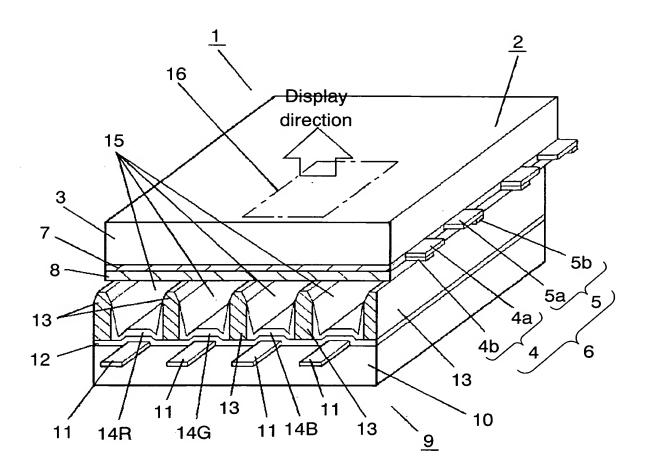
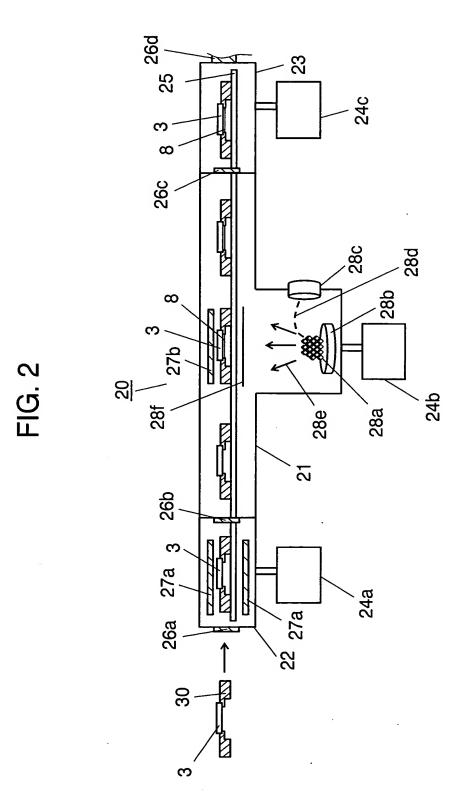
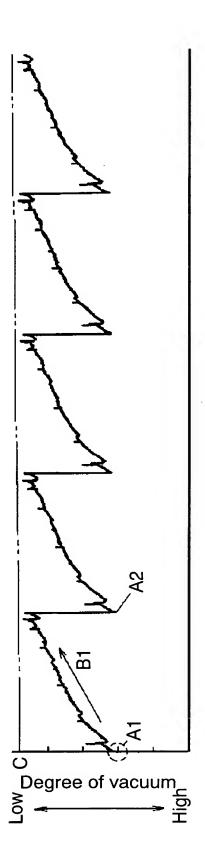
1/7 FIG. 1





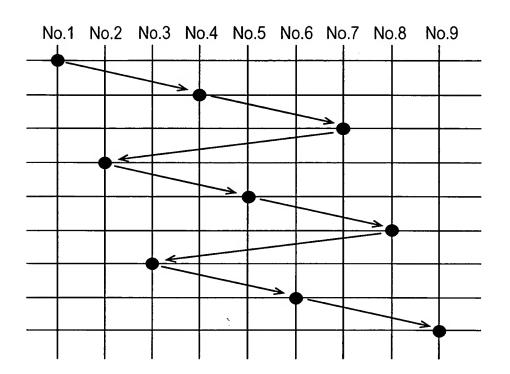




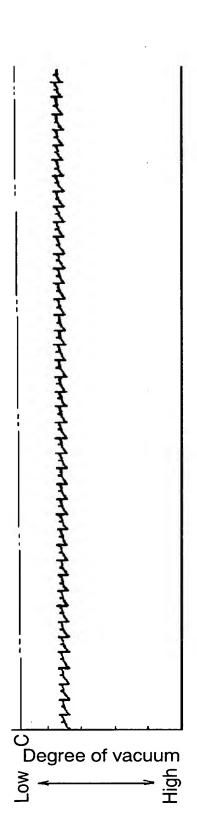
4/7 FIG. 4

Substrate holder No.

Replacement







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FIG. 6A

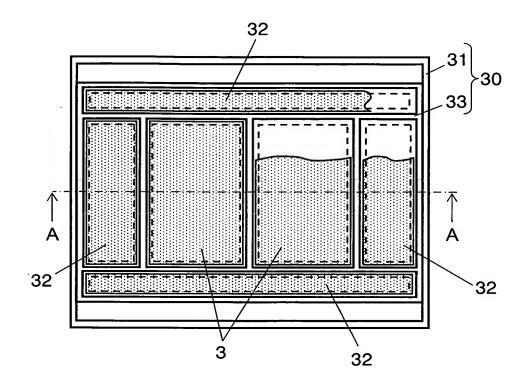


FIG. 6B

32
33
31
30
32
31
30

Reference Marks in the Drawings

- 1 plasma display panel
- 2 front plate
- 3 front substrate
- 4 scan electrode
- 4a, 5a transparent electrode
- 4b, 5b bus electrode
- 5 sustain electrode
- 6 display electrode
- 7, 12 dielectric layer
- 8 protective layer
- 9 back plate
- 10 back substrate
- 11 address electrode
- 13 barrier rib
- 14R, 14B, 14G phosphor layer
- 15 discharge space
- 20 deposition device
- 21 evaporating room
- 22 substrate carry-in room
- 23 substrate carry-out room
- 24a, 24b, 24c vacuum discharging system
- 25 transport means
- 26a, 26b, 26c dividing wall
- 27a, 27b heating lamp
- 28a vapor-deposition source
- 28b hurst
- 28c electron gun
- 28d electron beam
- 28e vapor stream
- 28f shutter
- 30 substrate holder
- 31 first substrate retainer
- 32 dummy substrate
- 33 second substrate retainer